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2018

Jin, T., Kumar, D., Gan, W., Ranjbar, M., Luo, F., Sbiaa, R., . . . Piramanayagam, S. N. (2018). Nanoscale compositional modification in Co/Pd multilayers for controllable domain wall pinning in racetrack memory. *Physica Status Solidi (RRL) – Rapid Research Letters*, 12(10), 1800197-. doi:10.1002/pssr.201800197

<https://hdl.handle.net/10356/137507>

<https://doi.org/10.1002/pssr.201800197>

This is the accepted version of the following article: Jin, T., Kumar, D., Gan, W., Ranjbar, M., Luo, F., Sbiaa, R., . . . Piramanayagam, S. N. (2018). Nanoscale compositional modification in Co/Pd multilayers for controllable domain wall pinning in racetrack memory. *Physica Status Solidi (RRL) – Rapid Research Letters*, 12(10), 1800197-. doi:10.1002/pssr.201800197, which has been published in final form at <https://doi.org/10.1002/pssr.201800197>. This article may be used for non-commercial purposes in accordance with the Wiley Self-Archiving Policy [<https://authorservices.wiley.com/authorresources/Journal-Authors/licensing/self-archiving.html>].

Nanoscale compositional modification in Co/Pd multilayers for controllable domain wall pinning in racetrack memory

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Abstract

In the era of social media, storage of information plays an important role. Magnetic domain wall memory devices are promising alternatives to hard disk drives for high-capacity storage. One of the challenges in making these devices practice application is a precise control of domain wall displacement in nanowires. Researchers have extensively studied domain wall pinning based on topographical notches fabricated by lithography. However, scaling the domain wall memory to nanoscale requires better domain wall pinning strategies. We demonstrate that the localized modification of magnetic properties in Co/Pd multilayers-based nanowires by ion implantation is an effective non-topographical approach to pin domain walls. First, we show by micromagnetic simulations that the areas, where the composition is modified to tune the anisotropy and magnetization, act as domain wall pinning centers. Experimentally, we show from magnetization measurements and X-Ray diffraction measurements at the thin film level that the ion-implantation is effective in changing magnetic anisotropy. We also fabricated devices and show using Kerr images at different applied fields that the domain walls are pinned at the B⁺ ion implanted regions. These results demonstrate that localized compositional modification using ion-implantation can pin domain walls precisely. The achieved results are useful towards realizing high-capacity information storage.

Keywords: Domain wall memory, domain wall pinning, compositional modification, ion implantation, Co/Pd multilayers

1. Introduction

Domain wall (DW) based devices such as racetrack memory have been proposed as promising candidates for high capacity, non-volatile information storage to replace hard disk drives.^[1,2] In DW memory (DWM) with a perpendicular magnetic anisotropy (PMA), the domains with magnetization pointing up represent “1” and the regions with magnetization pointing down represent “0”.^[2,3] In order to read and write information, the DWs are moved by an electrical current which causes motion by the spin transfer torque (STT) mechanism.^[4-7] Spin Hall effect in heavy metal/ferromagnetic/insulator structures is another mechanism in which a torque is exerted by pure spin current.^[8,9] In comparison to STT driving DW motion, pure spin polarized current gives a high speed performance of DW devices.^[10,11] The speed of DW motion in certain designs could reach km/s.^[11] In order to increase the capacity of DWM, researchers proposed fabricating U-shape vertical nanowire to store data, like the trees planted in the forest. However, fabrication of such devices is challenging particularly for commercial purposes. The other structure is horizontal stripe shape, which suffers from the data storing overflowing issues because the two ends of nanowire cannot be connected. Zhang et al. proposed a ring structure with DW ratchets, which could be utilized for addressing the data overflow issue without any additional overhead.^[12]

For DW based devices, the propagation of DWs show a stochastic behavior. This stochastic manner also remains as a significant challenge for magnetic recording community to achieve the high density storage.^[13,14] For this reason, the hard disk media industry moved from the use of continuous magnetic thin films to exchange-decoupled granular thin films, whereby the magnetization reversal by DW zig zag motion was completely avoided.^[15-17] Therefore, for reliable operation of ultra-high density DW devices, precise control of DW motion is important.^[18-20]

In the studies carried out so far, the pinning sites for DW devices were fabricated by traditional lithography process by modifying the geometry, e.g., creation of notches or staggered patterns in the ferromagnetic nanowire.^[21-23] Exchange bias field to pin DWs has also been proposed in the past.^[24] The pinning fields were introduced at the cross points by ferromagnetic wires and antiferromagnetic wires via

exchange coupling between the two wires. Recently, we have proposed compositional modification using annealing induced diffusion as a possible step to pin DWs.^[25] There are also some reported studies about pinning DW by tuning anisotropy using focused ion beam irradiation.^[26-32] In this letter, we propose an alternative approach, which is based on ion-implantation induced local modification of magnetic properties for controlling DW displacement in Co/Pd multilayers-based DW devices. In comparison to focused ion beam technique, ion-implantation offers a variety of elements for selection and implantation through mask is easy to be adapted for mass manufacturing. At first, we carried out micromagnetic simulations to investigate if DWs could be pinned by local compositional variation. Secondly, we carried out experimental investigations to understand the effects of ion-implantation on the magnetic and structural properties of Co/Pd multilayers. As a next step, we demonstrated DW pinning in the fabricated devices using the proposed method. Finally, we show STT driven domain wall motion and effective pinning by simulation results. The results highlighted in this report are useful in the development of DW memory devices.

2. Simulation

We first studied the DW position as a function of time using Mumax3. The time-dependent magnetization dynamics under applying current is expressed by using the extended Landau-Lifshitz-Gilbert (LLG) equation, which has been taken into account both the adiabatic and non-adiabatic terms of STT.^[33,34]

$$\frac{d\mathbf{M}}{dt} = -\gamma_0 \mathbf{H}_{\text{eff}} \times \mathbf{M} + \frac{\alpha}{M_s} \mathbf{M} \times \frac{d\mathbf{M}}{dt} + \mathbf{\Gamma}_{\text{STT}} \quad (1)$$

Here, γ_0 is the Gilbert gyromagnetic ratio, α is the Gilbert damping coefficient and M is the magnetization. The H_{eff} in Eq. (1) is the effective field acting on the local magnetization M which includes perpendicular anisotropy and magnetostatic interaction. The spin transfer torque $\mathbf{\Gamma}_{\text{STT}}$ generated by current can be expressed by the following relation:

$$\mathbf{\Gamma}_{\text{STT}} = -(a_J / M_s) \mathbf{M} \times (\mathbf{M} \times \mathbf{P}) - b_J (\mathbf{M} \times \mathbf{P}) \quad (2)$$

Where $\mathbf{P}$ is the spin polarization vector, a_J is the strength of anti-damping torque effect and b_J is the strength of field-like torque effect.

Two types of nanowire devices of Co/Pd multilayer structure (Type A: with length of 128 nm, width of 16 nm and the thickness of 2 nm and Type B: length of 5120 nm, width of 1280 nm and thickness of 10 nm), were used in the simulation. Fig. 1 shows the simulation results of type A structures. We chose the material properties of Co/Pd multilayers at the unimplanted areas, viz., $M_s = 400$ emu/cc and magnetic anisotropy energy $K_u = 5 \times 10^6$ erg/cc and defined the areas where compositional modification were carried out to have a lower saturation magnetization M_s (200 emu/cc) and lower magnetic anisotropy energy $K_u = 1 \times 10^6$ erg/cc. All through simulation, a discretization of $2 \text{ nm} \times 2 \text{ nm} \times 2 \text{ nm}$ is used which is sufficiently smaller than the exchange length.^[35]

Fig 1(a1-a3) shows DW propagation in nanowires without domain wall pinning sites. In these wires, M_s and K_u are uniform throughout the length, representing a wire with no implantation induced local modification. When a current was sent with a density of 5×10^{10} A/m², the domain walls propagated to the end of nanowire without stopping. The domain wall velocity was found to be 8 m/s.^[36] Fig. 1(b1-b3) illustrates the scenario for the nanowires with modified regions. It can be noticed that the DW stopped at the region and became widen. When the spin-polarized current was increased to 2×10^{11} A/m², DW was depinned and moved to the end of nanowire. Therefore, the simulation results indicate that the proposed scheme has the potential to pin DWs in a controllable manner. Detailed description of further simulation studies are presented at the end of this letter.

Figure 1 Micromagnetic simulation studies of DW propagation in two magnetic nanowires (a) without pinning sites and (b) with periodic pinning sites which have different magnetic properties from other regions. (a1-a3) depicts the domain wall position at different times in nanowires without pinning sites. (b1-b3) depicts the domain wall position at different times in nanowires where local modification of magnetic properties were carried out to create pinning sites. A spin current with a current density of $5 \times 10^{10} \text{ A/m}^2$ was used to move DWs. The dashed boxes show the modified area.^[35]

3. Results and Discussion

In order to demonstrate the pinning of DWs by the compositionally modified areas experimentally, we used a Co/Pd multilayer films with a perpendicular magnetic anisotropy. N multilayers films with different thickness were deposited using DC magnetron sputtering system. As shown in Fig. 2 (a), the films consists of Si (SiO_2)/ Ta (5 nm)/Cu (5 nm) /Pd (3 nm)/[Co (0.3 nm)/Pd (0.8 nm)]_N/Ta (5 nm), where N (=5, 10 and 15) indicates the repeating cycles in each film. The magnetic properties of each film were characterized by Alternating Gradient Force Magnetometer (AGFM) along the out of plane (OOP) and in-plane (IP) directions. The characterized magnetic hysteresis loops (M-H) are shown in Fig. 2 (b). The rectangular loops for [Co/Pd]_{5,10,15} bilayers indicate the presence of a strong

PMA in each film, as seen from the OOP measurement. The inset in Fig. 2 (b) shows the strong perpendicular magnetic anisotropy according to the difference behavior of out-of-plane and in-plane hysteresis loops of Co/Pd multilayers sample with $N=15$. The wafer with deposited film were then diced divided into two different groups to compare the magnetic properties with and without ion-implantation. A 10 keV B^+ implantation was carried out at a fluence of 5×10^{15} ions/cm² to achieve the compositional modification on one group of the films.

Figure 2 (a) Schematic illustration of a sample stack structure used in this study and (b) Out-of-plane (OOP) hysteresis loops of Co/Pd multilayers with different values of N . The insert figure shows the In-plane (IP) and Out-of-plane (OOP) hysteresis loops of [Co/Pd]₁₅.

The magnetic properties of the B^+ ion implanted samples were characterized by AGFM along the OOP direction and polar Kerr imaging microscopy after ac demagnetization in a OOP field. The hysteresis loops are shown in Fig. 3, where the OOP hysteresis loops characterized from the unimplanted samples are included for comparison. Changes of the OOP hysteresis loops were observed from the two group samples, as shown in Fig. 3 (a, d and g). The hysteresis loops of implantation [Co/Pd]_{5,10} samples, which vary from that of the non-implantation samples, indicate that the implanted [Co/Pd]_{5,10} samples have no PMA and the magnetizations lie in-plane. The same results can be confirmed from the domain images. All the unimplanted samples show micro-size stripe domains with a strong contrast, which are typical of films with a PMA, as shown in Fig. 3 (b, e), but after B^+ implantation, the stripe domains

disappear, as shown in Fig. 3 (c, f). The PMA of the implantation sample with $N=15$ decreases, compared to the unimplanted ones, as shown in Fig. 3 (g). The stripe domains in $N=15$ sample becomes weaker after implantation, as compared in Fig. 3 (h) and (i). In general, the anisotropy decreases for the B^+ implantation samples. We propose that the decline is attributed to the change of Co/Pd interfaces caused by the implantation, as the PMA arises from Co and Pd interface.^[37-41]

Figure 3 (a, d and g) Hysteresis loops of $[\text{Co/Pd}]_N$ multilayers with different values of N , with and without implantation. Domain images of $[\text{Co/Pd}]_N$ multilayers with different values of N , (b, e and h) before implantation and (c, f and i) after implantation. The black and grey regions represent magnetization in two different orientations (into the paper and out-of-paper, for example).

X-Ray Diffraction (XRD) measurements were carried out on unimplanted and implanted samples to validate our hypothesis. The measurement results are shown in Fig. 4. For the unimplanted case, the samples show a peak at 40.8, 41 and 41.1 degrees for N=5, 10 and 15 respectively. The peaks follow the widely reported behavior that the peak position depends on the relative thickness of Co and Pd layers in Co/Pd multilayer systems.^[18,19] Since pure Pd (111) exhibits a peak at around 40.8 degrees and pure Co (111) exhibits a peak at around 44.4 degrees, the Co/Pd multilayers exhibits a peak in between these two angles, depending on the relative thickness of Co and Pd. The peak position also varies with the number of bilayers. In the case of N=15, there are more Co layers in comparison to the sample with N=5 and hence the peak shifts towards the higher angles (closer toward the Co (001) peak). For the B⁺ implantation group, the peak shifts towards lower 2 θ values, compared to the unimplanted group. This implies that the Co and Pt interfaces of B⁺ implanted samples vary from those of unimplanted samples. The shift magnitude is 0.59, 0.45 and 0.32 degrees for N=5, 10 and 15, which indicates that it has an inverse dependence on the value of N. The shift is partially attributed to the intermixing of Co and Pd caused by the implantation as verified later by Transport of Ions in Matter (TRIM) simulation. Due to the intermixing, for small values of N, layers that had predominantly Co become mixed with Pd atoms due to ion-implantation. As a result, the peak shifts towards lower values of 2 θ . The B⁺ occupation in the interstitial positions, which can result in further shift towards lower 2 θ values, also contributes to the shift. However, the shift due to B⁺ occupation is not significant for samples with N=15, because the penetration of B⁺ is not deep.^[37]

Figure 4 XRD peaks of samples with different values of N, with and without B⁺ implantation.

In order to understand the intermixing of Co and Pd, we carried out TRIM simulation of the distribution of Co and Pd atoms displaced from their initial positions.^[37,42] The diffusion between Co and Pd atoms is clear for N=5 and 10 as shown in in Fig. 5. For N=15, the diffusion between Co and Pd is not significant. This inter-diffusion corroborates with the reduction in the magnetic anisotropy and the XRD results.

Figure 5 The distribution of displaced atoms (obtained from TRIM simulation) of Co and Pd after B⁺ implantation (a) For N=5, (b) for N=10 and (c) for N=15 bilayers. The dashed lines indicate the middle portion of the Co and Pd layers before ion implantation. The Co and Pd layers were assumed to be sharp before implantation, as shown in illustration (d). After implantation, the atoms are diffused as illustrated in (e).

The investigations so far indicate that the B⁺ implantation causes the changes in the magnetic and structural properties of Co/Pd multilayers. In order to demonstrate that such modified areas act as pinning centers in experiments, a [Co/Pd]₁₀ nanowire device with localized B⁺ implantation was fabricated by E-beam lithography. The fabrication process can be seen in sample preparation section. Kerr imaging system was used to observe the DW nucleation and motion. Initially, the nanowire device was magnetized to saturation to eliminate DWs. Kerr image shows gray regions, (Fig. 6 (a)), which indicates that there are no DW in the device after saturation. Later, a 10 mA pulse current with 1ms width was sent through the

injection line to give rise to Oersted field to nucleate DWs in the wire devices.^[43,44] As shown by Kerr image in Fig. 6 (b), two magnetic domains which are in black were generated beside the cross-bar. (The reason for the small domain at the right side is not clear). The reversal magnetic field was increased gradually. At an external magnetic field of 900 Oe, the DW moved to the pinning centre, as evidenced by the expansion of the black region to the position where the B⁺ implantation is located. The black region does not expand further when the applied field was increased to 910 Oe, which indicates that the DW is pinned at this position. This fact implies that the pinning center formed by B⁺ implantation in this region is effective. When the external magnetic field was increased to 920 Oe, the black region moved across the implantation position and spread to the end of the device. Hence, it can be concluded that the implantation region acts as a pinning center to stabilize the DWs, and the pinning and depinning field are close to 900 and 920 Oe respectively. It may be argued that the geometrical modification around the small cross-bar due to ion-implantation is a possible cause of pinning. However, we believe that this effect is negligible, as the depinning field is much larger (920 Oe) than observed in the case of geometrical modification, such as notches (100 Oe).^[45-47]

Figure 6 (a) Kerr images which show the nanowire device with the saturation state. (b) DW nucleation at the cross-bar and (c and d) the DW propagation by applying different magnetic fields along perpendicular direction.

In order to understand how effective would be the pinning in the case of STT-induced DW motion, we carried out further micromagnetic simulations. For this study, we used type B structures, which resemble our experimental devices closely. Figure 7 shows the values of anisotropy constant (K_u) and the saturation magnetization (M_s) of the implanted regions. When a current was sent through the device, the domain walls moved and got pinned in the regions with a lower K_u or M_s . When the current density was increased further, the domain walls got depinned and moved further. The current density associated with depinning J_{dep} is shown in the table and in the graph. It can be noticed from the table that the depinning current density increases when both K_u and M_s decreases (diagonal direction of the table). In the case of ion-implantation, both K_u and M_s are expected to decrease. So, this trend is a clear indication that the ion-implantation induced local modification is a good technique to pin the domain walls. The graph shows the trend of J_{dep} as a function of $\text{Mod}(H_{kw}-H_{kp})$ where H_{kw} is the anisotropy field of the wire and H_{kp} is the anisotropy field of the pinning region, obtained from the relation $H_k = 2K_u/M_s$. In general, an increase in the value of J_{dep} associated with an increase in the difference between H_{kw} and H_{kp} is noticed. These results further confirm that the ion-implantation induced changes in local magnetic properties can help in forming pinning centres.

Figure 7 (a) Tabulation of depinning current density J_{dep} for pinning regions with various values of K_u and M_s . (b)

Plot of depinning current density J_{dep} for pinning regions with various values of K_u and M_s .

4. Conclusions

In conclusion, the DW pinning method using compositional modifications by ion implantation has been investigated. This method has been validated by simulations and experiments. We have observed that B^+ implantation can reduce the anisotropy of the Co/Pd multilayers and change the magnetization from perpendicular to in-plane direction. In $[Co/Pd]_{10}$ nanowire study, the pinning field can be as high as 920 Oe.

Acknowledgments

We gratefully acknowledge Nanyang Technological University Start-Up Grant and AcRF-Tier 1 grant RG163/15 for the funding of this research. We would like to acknowledge Calvin Ang Ching Ian for his help in Kerr microscopy measurement.

References

- [1] J. S. Meena, S. M. Sze, U. Chand, T. Y. Tseng, *Nanoscale Res. Lett.* **2014**, 9, 526.
- [2] Z. T. Diao, Z. J. Li, S. Y. Wang, Y. F. Ding, A. Panchula, E. Chen, L. C. Wang, Y. M. Huai, *J. Phys. Condens. Matter.* **2007**, 19, 165209.
- [3] R. Sbiaa, H. Meng, S. N. Piramanayagam, *Phys. Status Solidi RRL.* **2011**, 5, 413.
- [4] J. Slonczewski, *J. Magn. Magn. Mater.* **1996**, 159, L1.
- [5] D. Chiba, G. Yamada, T. Koyama, K. Ueda, H. Tanigawa, S. Fukami, T. Suzuki, N. Ohshima, N. Ishiwata, Y. Nakatani, T. Ono, *Appl. Phys. Express* **2010**, 3, 073004.
- [6] R. Sbiaa, S.N. Piramanayagam, *Phys. Status Solidi RRL.* **2017**, 11, 1700163.
- [7] S. Bhatti, R. Sbiaa, A. Hirohata, H. Ohno, S. Fukami, S. N. Piramanayagam, *Mater. Today* **2017**, 20, 530.
- [8] O. Boulle, G. Malinowski, M. Kläui, *Mater. Sci. Eng. R. Rep.* **2011**, 72, 159.
- [9] S. Emori, U. Bauer, S. M. Ahn, E. Martinez, G. S. Beach, *Nat. Mater.* **2013**, 12, 611.
- [10] S. Parkin, S. H. Yang, *Nat. Nanotechnol.* **2015**, 10, 195.
- [11] S. H. Yang, K. S. Ryu, S. Parkin, *Nat. Nanotechnol.* **2015**, 10, 221.
- [12] Y. Zhang, X. Y. Zhang, J. T. Hu, J. Nan, Z. Y. Zheng, Z. Z. Zhang, Y. G. Zhang, N. Vernier, D. Ravelosona, W. S. Zhao, *Sci. Rep.* **2016**, 6, 23164.
- [13] S. N. Piramanayagam, *J. Appl. Phys.* **2007**, 102, 011301.
- [14] Y. H. Tang, J. G. Zhu, *IEEE Trans. Magn.* **2007**, 43, 2139.
- [15] S. N. Piramanayagam, B. Varghese, Y. Yang, W. K. Lee, H. K. Tan, *J. Appl. Phys.* **2014**, 115, 243901.
- [16] D. Weller, G. Parker, O. Mosendz, A. Lyberatos, D. Mitin, N. Y. Safonova, M. Albrecht, *J. Vac. Sci. Technol. B.* **2016**, 34, 060801.
- [17] N. Xiao, B. Yang, J. S. Wang, S. Li, Y. P. Ren, G. W. Qin, *Rare Metals* **2016**, 35, 463.
- [18] M. Albert, M. Franchin, T. Fischbacher, G. Meier, H. Fangohr, *J. Phys. Condens. Matter.* **2012**, 24, 024219.
- [19] M. Y. Im, L. Bocklage, P. Fischer, G. Meier, *Phys. Rev. Lett.* **2009**, 102, 147204 .
- [20] A. Vogel, S. Wintz, J. Kimling, M. Bolte, T. Strache, M. Fritzsche, M.Y. Im, P. Fischer, G. Meier, J. Fassbender, *IEEE Trans. Magn.* **2010**, 46, 1708.
- [21] S. S. Parkin, X. Jiang, C. Kaiser, A. Panchula, K. Roche, M. Samant, *Proc. IEEE 91* **2003**, 661-680.
- [22] R. Sbiaa, M. Al Bahri, *J. Magn. Magn. Mater.* **2016**, 411, 113.
- [23] M. Al Bahri, R. Sbiaa, *Sci. Rep.* **2016**, 6, 28590.
- [24] A. J. V. I. Polenciuc, D. A. Allwood, T. J. Hayward, G. Vallejo-Fernandez, K. O'Grady and A. Hirohata, *Appl. Phys. Lett.* **2014**, 105, 162406.
- [25] T. L. Jin, M. Ranjbar, S. K. He, W. C. Law, T. J. Zhou, W. S. Lew, X. X. Liu, S. N. Piramanayagam, *Sci. Rep.* **2017**, 7, 16208.
- [26] J. H. Franken, M. Hoeijmakers, R. Lavrijsen, H. J. Swagten, *J. Phys.: Condens. Matter* **2012**, 24, 024216.
- [27] T. Gerhardt, A. Drews, G. Meier, *J. Phys.: Condens. Matter* **2012**, 24, 024208.
- [28] J. A. King, A. Ganguly, D. M. Burn, S. Pal, E. A. Sallabank, T. P. A. Hase, A. T. Hindmarch, A. Barman, D. Atkinson, *Appl. Phys. Lett.* **2014**, 104, 242410.
- [29] D. M. Burn, D. Atkinson, *J. Appl. Phys.* **2014**, 116, 163901.
- [30] J. H. Franken, M. Hoeijmakers, R. Lavrijsen, J. T. Kohlhepp, H. J. M. Swagten, B. Koopmans, E. van Veldhoven, D. J. Maas, *J. Appl. Phys.* **2011**, 109, 07D504.
- [31] J. H. Franken, M. A. J. van der Heijden, T. H. Ellis, R. Lavrijsen, C. Daniels, D. McGrouther, H. J. M. Swagten, B. Koopmans, *Adv. Funct. Mater.* **2014**, 24, 3508.
- [32] R. Lavrijsen, G. Malinowski, J. H. Franken, J. T. Kohlhepp, H. J.M. Swagten, B. Koopmans, M. Czapkiewicz, T. Stobiecki, *Appl. Phys.Lett.* **2010**, 96, 022501.

- [33] A.V. Khvalkovskiy, K. A. Zvezdin, Y.V. Gorbunov, V. Cros, J. Grollier, A. Fert, A. K. Zvezdin, *Phys. Rev. Lett.* **2009**, *102*, 067206.
- [34] S. Zhang, Z. Li, *Phys. Rev. Lett.* **2004**, *93*, 120201.
- [35] R. Sbiaa, S. N. Piramanayagam, *Appl. Phys. A* **2014**, *114*, 1347.
- [36] S. Gadetsky, *IEEE Trans. Magn.* **1995**, *31*, 3361.
- [37] N. Gaur, K. K. M. Pandey, S. L. Maurer, S. N. Piramanayagam, R. W. Nunes, H. Yang, C. S. Bhatia, *J. Appl. Phys.* **2011**, *110*, 083917.
- [38] N. Gaur, S. N. Piramanayagam, S. L. Maurer, R. W. Nunes, S. Steen, H. Yang, C. S. Bhatia, *J. Phys. D Appl. Phys.* **2011**, *44*, 365001.
- [39] Ikhtiar, K. Mukaiyama, S. Kasai, K. Hono, *Appl. Phys. Lett.* **2017**, *111*, 202407.
- [40] A. Krichevsky, A. Lavrenov, N. Amos, B. Hu, K. Taylor, S. Khizroev, *Journal of Nanoelectronics and Optoelectronics* **2008**, *3*, 274.
- [41] B. Tudu, A. Tiwari, *Vacuum*, **2017**, *146*, 329.
- [42] N. Gaur, S. Kundu, S. N. Piramanayagam, S. L. Maurer, H. K. Tan, S. K. Wong, S. E. Steen, H. Yang, C. S. Bhatia, *Sci. Rep.* **2013**, *3*, 1907.
- [43] S. H. Li, S. Goolaup, J. Kwon, F. L. Luo, W. L. Gan, W. S. Lew, *Sci. Rep.* **2017**, *7*, 972.
- [44] M. Ramu, S. Goolaup, W. L. Gan, S. Krishnia, G. J. Lim, W. S. Lew, *Appl. Phys. Lett.* **2017**, *110*, 162402.
- [45] L. K. Bogart, D. Atkinson, K. O'Shea, D. McGrouther, S. McVitie, *Phys. Rev. B* **2009**, *79*, 054414.
- [46] Y. Gao, B. You, X. Z. Ruan, M. Y. Liu, H. L. Yang, Q. F. Zhan, Z. Li, N. Lei, W. S. Zhao, D. F. Pan, J. G. Wan, J. Wu, H. Q. Tu, J. Wang, W. Zhang, Y. B. Xu, J. Du, *Sci. Rep.* **2016**, *6*, 31908.
- [47] Y. Gao, B. You, H. L. Yang, Q. F. Zhan, Z. Li, N. Lei, W. S. Zhao, J. Wu, H. Q. Tu, J. Wang, L. J. Wei, W. Zhang, Y. B. Xu, J. Du, *AIP Adv.* **2016**, *6*, 105301.

Experimental Section:

Sample Preparation

Thin film stack of Ta (5 nm)/Cu (5 nm) /Pd (3 nm)/[Co (0.3 nm)/Pd (0.8 nm)]_N/Ta (5 nm), where N=5, 10 and 15, were deposited on thermally oxidized silicon substrates via DC magnetron sputtering at room temperature. The bilayers Co and Pd were growth at the DC power of 40 W and the deposition rate of Co and Pd is 0.4 nm/s and 0.357 nm/s, respectively.

The Co/Pd multilayers-based microwires fabrication was carried out by E-beam lithography (EBL). The Co/Pd multiplayers thin film was patterned to 1 μ m wires under 20keV voltage and 7 μ m aperture. After E-beam exposure, Ar ion-milling was done to eliminate the unwanted film. The resist PMMA with the thickness of 200 nm over Co/Pd multilayers-based microwires were exposed under 10keV voltage and 30 μ m aperture. After developing, B⁺ ions were implanted in the holes of the resist. The B⁺ ions were with the energy of 10 keV which were at a fluence of 5 $\times$ 10¹⁵ ions/cm². After this, the DW injection line and electrode pads were exposed under 20keV and 120 μ m aperture and after developing, Ti (10 nm)/Au (80 nm)/ Ti (10 nm) were deposited in order to inject DW and cause DW motion by applying pulse current.

Sample Characterization

Normalized magnetic hysteresis loops (M-H) of Co/Pd multilayers thin film along in plane (IP) and out of plane (OOP) directions were carried out at room temperature by using Alternating Gradient Force Magnetometer (AGFM) with the magnetic sweeping from -20kOe to 20kOe. X-ray diffraction (XRD) with Cu-K α source was used for the structural analysis of the samples. Transport of ions in matter (TRIM) program was used to simulate the distribution of host atoms after B⁺ implantation. Domain images were carried out by using Polar Kerr imaging technique after ac demagnetization along OOP direction. In the demagnetization process, the magnetic field was cycled to zero with the step of 25 Oe decreasing from 4500 Oe, producing a demagnetized state. Direct observation of the DW pinning process was carried out using Polar Kerr imaging technique.